COURSE SYLLABUS

| University | Alexandru Ioan Cuza University of Iași | Course title | | |
|------------|---|---|----------------------|--|
| Faculty | Physics | | | |
| Department | Physics | Methods for Surface Analysis | | |
| Domain | Physics | Course category (FC/SC/CC ¹): SC | Term (1-4): 2 | |
| Level | Postgraduate (MA) | Course type (Co/El/F ²):Co | | |

I. Course structure

| Nu | umber of ho | ours/we | eek | Credits | Total class hours/ semester | Total hours of individual activity | Examination type (C/Ex/CE ³) | Teaching language |
|----------|--------------|------------------|--------------|---------|-----------------------------------|--|--|-------------------|
| Course 2 | Seminar - | Lab. 2 | Project - | 6 | 56 | 124 | Ex | English |

II. Instructors

| | Academic | Scientific | Name and surname | Faculty position (tenure/ |
|------------|---------------------|------------|------------------|---------------------------|
| | degree ⁴ | degree | | associate - organization) |
| Course | Professor | PhD | NEAGU Maria | tenure |
| Seminar | - | - | - | - |
| Laboratory | Lecturer | PhD | POHOATA Valentin | tenure |

III. Prerequisites

Mechanic and acoustics, Electricity, Magnetism, Optics.

IV. Course objectives

Imparting knowledge concerning fundamentals on physical principles and mesurement methods used for the surfaces characterisation. Understanding the theoretical knowledge by experiments. Capacities development for establishing measurement methods.

V. Course content

| Course | Surface properties. Optical microscopy. Interferometric methods. Elipsometric methods. Holographic methods. Magneto-optical methods. Atomic force microscopy. Diffraction methods. Fourier transform Infrared Absorption Spectroscopy: Attenuated total reflection (ATR) and Diffuse reflectance (DRIFTS). Auger electrons spectroscopy. Photoelectrons spectroscopy. Raman spectroscopy. Scanning electronic microscopy. | | | |
|------------|---|--|--|--|
| Seminar | - | | | |
| Laboratory | Study of the surfaces by optical microscopy. Determination of the optical constants and the thickenss of the thin films using the ellipsometry. Determination of the magneto-optic Kerr rotation and ellipticity for the soft magnetic thin films. Linnik interferometer: the study of the surfaces and determination of the thin films thickenss. Recording of the surface magnetic hysteresis of the magnetic thin films by magneto-optical Kerr effect. The study of the surfaces by atomic force microscopy. Recording and analysis of the oscillation spectra by attenuated total reflection method. Recording and analysis of the spectra by diffuse reflectance method. Study of the surfaces by scanning electron microscopy. | | | |

VI. Minimal required references

1. J. M. Walls, R. Smith, *Surface science techniques*, Elsevier Science Ltd (1994)

2. A. Eliașevici, Spectroscopie atomică și moleculară, Editura Academiei Române, București (1966)

 ¹ FC – fundamental course, SC – specialty course, CC – complementary course
² Co – compulsory, El – elective, F – facultative
³ C – colloquium, Ex – exam, CE – colloquium AND exam
⁴ Professor / Associate professor / Lecturer / Assistant professor / Teaching assistant

3. R. M. A. Azzam, N. M. Bashara, *Ellipsometry and polarized light*, North Holland Physics Publishing (1987)

VII. Didactic methods

Lecturing. Laboratory experiments.

VIII. Assessment

| Pre-conditions | Active participation to class activities. | | |
|----------------|---|-------|--|
| Exam dates | 1 st Assessment | April | |
| | 2 nd Assessment | June | |

| | Assessment means and methods | Percentage of the final grade |
|-----------------|------------------------------|-------------------------------|
| Exam/Colloquium | written | 50% |
| Seminar | - | - |
| Laboratory | laboratory colloquium | 50% |